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PATENT

10/032,930
Response to Restriction Requirement mailed June 6, 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Heikyung Min et al.

Appln. No.: 10/032,930

Filed: October 29, 2001

For: APPARATUS AND METHOD FOR
REDUCING SURFACE ZENER DRIFT
USING TI-BASED METALLURGY

Group Art Unit: 2818

Examiner: Dung Anh Le

RESPONSE TO RESTRICTION
REQUIREMENT MAILED JUNE 6, 2002

4/ *Electron*
G. S. only
7-17-02

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

The Examiner required that the above-identified application be restricted to claims 1-15 which are drawn to semiconductor device, or claims 16-20 which are drawn to a process of making a semiconductor device. As a result, applicants elect to prosecute claims 1-15

without traverse.

Respectfully submitted,

Dated: 6-20-02

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service, postage prepaid, in an envelope, addressed to Box _____, Commissioner for Patents, Washington D.C. 20231-9999 on 06-21-02.

Dated: 06-21-02 By: *Salvador B. Bue*

Atty. Docket No. 100-16800 (P05108)